



UL1000 Fab

Helium Leak Detector

REFINED PRECISION FOR THE SEMICONDUCTOR
LEAK DETECTION ENVIRONMENT



UL1000 Fab Helium Leak Detector meets semiconductor requirements

The INFICON UL1000 Fab Mobile Helium Leak Detector is specially designed to meet the exacting requirements of the semiconductor industry: testing flexibility, high sensitivity, fast and accurate results, quick start-up, mobility and system reliability. The UL1000 Fab is optimized to provide quick leak testing results for preventive maintenance, unscheduled repair, gas lines, and other leak testing applications.

The UL1000 Fab meets the requirements of the micro-electronics market. Features range from its sturdy metal housing, with cleanroom compatible wheels, to I-CAL*, the unbeatable algorithm for eliminating long averaging times for leak rates in the ultra-sensitive 10^{-11} and 10^{-12} leak rate ranges.

The system software includes advanced self-diagnosis routines with troubleshooting instructions. Protective functions can be called up to prevent contamination with helium or process gases. The ceiling-to-floor airflow commonly found in cleanrooms is not disturbed by the ventilation system of the UL1000 Fab. The pumping speed and compression of the turbomolecular pump reduce and rapidly eliminate helium contamination.

ULTRAFAST DETECTION DUE TO I-CAL

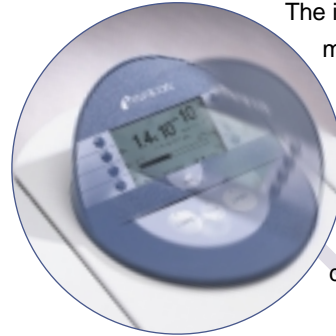
Using a special software algorithm called I-CAL, the UL1000 Fab provides measurements at unsurpassed speed in the 10^{-12} mbar l/s range, making that decade truly usable. While other leak detectors have to average the signals over minutes to achieve adequate stability, the UL1000 Fab with I-CAL responds with unparalleled speed and stability in this low measurement range.

For example, starting from a background reading of 1×10^{-12} mbar l/s, an ultra-tiny leak of 1×10^{-12} mbar l/s is displayed in less than a second.

* Intelligent Calculation Algorithm of Leak rates

CONVENIENT ROTATABLE DISPLAY

The UL1000 Fab offers a rotatable control interface.



The integrated display presents measurement results and status information in large characters with excellent clarity, so that readings can be observed conveniently from considerable distances.

The display mode can be selected as digital, bar graph, trend or circular. The most important basic functions (Start, Zero, Stop) are available at the press of a button. The software is menu-controlled and easy-to-use.

Parts of the menu can be protected against unauthorized use or unintended modifications.



MOBILE FOR ADDED CONVENIENCE

A low center of gravity, large wheels, ergonomically positioned handle and sleek profile ensure mobility throughout the facility.

The instrument's maneuverability is uncompromised by rolling vibrations on the floor grid or by barriers such as small steps, door thresholds or cables.

CONNECTIONS TO ONE SIDE



To simplify installation, all the electrical and mechanical connections are located together on one side of the instrument.

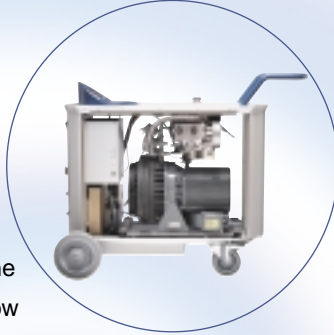
UL1000 Fab specially designed for cleanroom applications

VACUUM SYSTEM FOR ADDED CONFIDENCE

The vacuum system consists of a dry backing pump and a powerful turbomolecular pump with a high compression ratio.

With high pumping speed plus the turbopump's high inlet pressure, the system quickly reaches levels below the reject leak rate and leak checking can begin.

The multiple gas inlet on the turbopump allows optimization of detection limits to the pressure conditions in the component being tested.



APPLICATIONS:

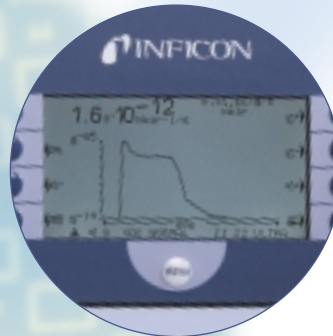
- maintenance work on semiconductor process tools, with or without support from their own pump
- inspections and installations of process-gas systems
- leak testing of components before they are installed in existing tools
- applications requiring high pumping speed and sensitivity plus clean testing conditions

INFICON leak detectors are manufactured in cleanrooms. All the components used, including valves and corrugated hoses, are oil-free and are built and tested under oil-free conditions.

SOFTWARE UPDATES VIA E-MAIL

System software updates are available via e-mail.

From your computer, the new firmware is installed via the standard interface within minutes.



3-YEARS WARRANTY ON ION SOURCE

By design, the ion source is extremely robust. Measures implemented in the UL1000 Fab protect the ion source from air blasts, contamination and other events that could shorten the filaments' service life.

However, should it need replacing, INFICON offers the only three-year warranty on the complete ion source.

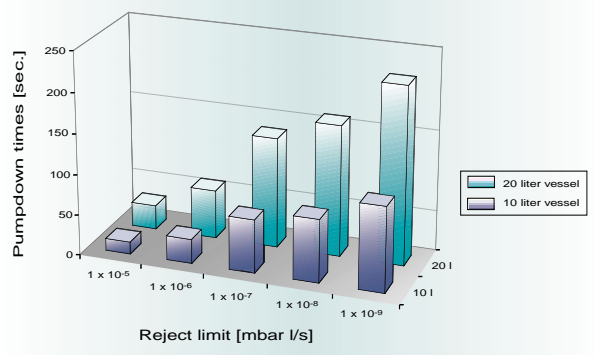
The UL1000 Fab provides superior leak testing efficiency in semiconductor applications.

You can expect fast, accurate, stable and repeatable results and have complete confidence in the tests performed with the UL1000 Fab.



PUMPDOWN TIMES

The graph to the right shows the pumpdown times required to reach the applicable reject leak rates for two vessel sizes.



TECHNICAL DATA

Smallest detectable leak rate (per AVS 2.1 and EN 1518)	< 5 x 10 ⁻¹² mbar l/s
Smallest detectable leak rate (sniffer mode)	< 1 x 10 ⁻⁷ mbar l/s
Inlet pressure	GROSS FINE ULTRA
	15 mbar 1 mbar 0.1 mbar
Pumping speed	During evacuation He pumping speed at the inlet (EN 1518)
	25 m ³ /h 2.2 l/s
Detectable masses	2, 3, 4 amu H ₂ , ³ He, He
Supply voltages	100-120 V; 220-240 V
Weight	110 kg; 242 lbs
Dimensions, incl. handle (L x W x H)	1068 x 525 x 850 mm; 42 x 21 x 33 in

ORDERING INFORMATION

UL1000 Fab, 230 volts	Cat. No. 550 100
UL1000 Fab, 115 volts	Cat. No. 550 101
Tool box, removable	Cat. No. 551 000
Remote control	Ref. No. 200 99 022



GLOBAL HEADQUARTERS:

Two Technology Place, East Syracuse, NY 13057 USA
Tel: +1.315.434.1100 Fax: +1.315.437.3803 E-mail: reachus@inficon.com

UNITED STATES FRANCE GERMANY LIECHTENSTEIN SWITZERLAND UNITED KINGDOM CHINA JAPAN KOREA SINGAPORE TAIWAN

Visit our website for contact information and other sales offices worldwide. www.inficon.com
Due to our continuing program of product improvements, specifications are subject to change without notice.

iiba01e1-a(0207) ©2002 INFICON